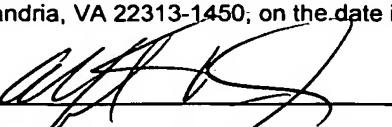


DKJ -

Docket No.: 2004P00018

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By: 

Date: November 29, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/591,879	Confirmation No.: N/A
Applicant	:	Christofer Hierold et al.	
Filed	:	September 5, 2006	
Title	:	Force Sensor	
Art Unit	:	N/A	
Examiner	:	to be determined	
Docket No.	:	2004P00018	
Customer No.	:	24131	

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97

Hon. Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

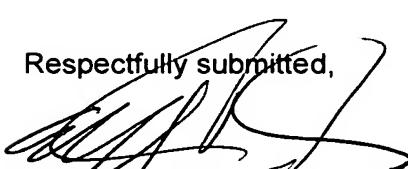
In accordance with 37 CFR § 1.98 copies of the following patents and/or publications are cited herewith:

Tombler et al.: "Reversible electromechanical characteristics of carbon nanotubes under local- probe manipulation", Nature, June 15, 2000;

Husain et al.: "Nanowire- based very- high- frequency electromechanical resonator", Applied Physics letters, August 11, 2003;

Toriyama Toshiyuki et al.: " Piezoresistance measurement on single crystal silicon nanowires", Journal of Applied Physics, January 1, 2003.

Respectfully submitted,


For Applicant

Alfred K. Dassler
52,794

Date: November 29, 2006
Lerner Greenberg Steiner LLP
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101 /bh

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR § 1.98(b))Attorney Docket No.:
2004P00018Applic. No.
10/591,879

Applicant

Christofer Hierold et al.

Filing Date
September 5, 2006Group Art Unit
N/A

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J						
	K						
	L						
	M						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	N	Tombler et al.: "Reversible electromechanical characteristics of carbon nanotubes under local- probe manipulation", Nature, June 15, 2000
	O	Husain et al.: "Nanowire- based very- high- frequency electromechanical resonator", Applied Physics letters, August 11, 2003
	P	Toriyama Toshiyuki et al.: " Piezoresistance measurement on single crystal silicon nanowires", Journal of Applied Physics, January 1, 2003

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.